

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No: To Be Assigned
Applicants: M. Kito et al.
Filed: Herewith
Title: SEMICONDUCTOR LASER DEVICE AND FABRICATION METHOD THEREOF
TC/A.U.:
Examiner:
Confirmation No.:
Docket No.: YAO-4316US1

Divisional of:

Appln. No: 09/521,512
Applicants: M. Kito et al.
Filed: March 8, 2000
Title: SEMICONDUCTOR LASER DEVICE AND FABRICATION METHOD THEREOF
TC/A.U.: 2828
Examiner: Quyen Phan Leung
Confirmation No.: 1089
Docket No.: YAO-4316US

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows:

- ☒ **Amendments to the Specification** begin on page 2 of this paper.
- ☒ **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.
- ☐ **Amendments to the Drawings** begin on page _____ of this paper and include an attached replacement sheet.
- ☐ **Amendments to the Abstract** are on page _____ of this paper. A clean version of the Abstract is on page _____ of this paper.
- ☒ **Remarks/Arguments** begin on page 5 of this paper.